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**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE --
EXAMINING GROUP 1792**

PATENT

Attorney Docket No.: 016301-047800US

Client Ref. No.: AMAT No.
907188/DISPLAY/AKT/BG

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Sheng Sun et al.

Application No.: 10/817,611

Filed: April 2, 2004

For: METHOD AND SYSTEM FOR
CONTROL OF PROCESSING
CONDITIONS IN PLASMA
PROCESSING SYSTEMS

Customer No.: 57385

Confirmation No. 2449

Examiner: Joel G. Horning

Technology Center/Art Unit: 1792

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Commissioner for Patents
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Commissioner:

In response to the final Office Action mailed August 19, 2009, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.